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Attorney's Docket No.: 042390P13229D

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: )

Andideh, Ebrahim )

U.S. Serial No: 10/662,094 )

Examiner: Erdem, Fazli

Filed: September 12, 2003 )

Art Unit: 2826

For: A METHOD OF FORMING A )  
LOW-DIELECTRIC CONSTANT )  
STRUCTURE WITH A MULTILAYER )  
STACK OF THIN FILMS WITH PORES )  
(as amended) )

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE**

Dear Sir:

This is in response to the Office Action mailed June 4, 2004. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

on October 26, 2004

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

Teresa Mattox

Signature

October 26, 2004

Date

Serial No. 10/662,094

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